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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Takatomo SASAKI et al.

Attn: **BOX PCT**

Serial No. NEW

Docket No. 2001 1739A

Filed November 23, 2001

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

METHOD AND APPARATUS FOR GROWING HIGH QUALITY SINGLE CRYSTAL

[Corresponding to PCT/JP00/03264]

[FEDERAL BUREAU OF INVESTIGATION]
Filed May 22, 2000]

PRELIMINARY AMENDMENT TO REDUCE PTO FILING FEE

Assistant Commissioner for Patents,
Washington, DC 20231

Sir:

Please amend the above-identified application as follows.

In the Claims:

Kindly amend claims 5 and 15 as follows.

5. (Amended) A method according to claim 3, wherein a single crystal of an oxide is grown.

15. (Amended) An apparatus for growing a single crystal of an oxide comprising the growing apparatus as claimed in claim 13.